

Abstract

Cleaning Process and Apparatus

5

A cleaning module for cleaning one or more substrates, more particularly but not exclusively for cleaning aluminium discs, is disclosed. In particular, the cleaning module comprises one or more brushes operable to move along a radial path in relation to the substrate. In addition, a method of positioning at least one brush during the cleaning of the substrate by moving the brush along a radial path in relation to the substrate is also disclosed. Finally, a method of cleaning the substrate by moving the brush along the radial path in relation to the substrate and overlapping a scrubbing portion of the brush with a corresponding portion of the at least one substrate is disclosed.

15

Figure 4



162162



G00002